



**ELECTRONIC COPY**

LG764660773  
Report verification at igi.org



May 14, 2026  
IGI Report Number **LG764660773**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **13.27 X 8.93 X 5.18 MM**  
**GRADING RESULTS**  
Carat Weight **4.00 CARATS**  
Color Grade **E**  
Clarity Grade **INTERNALLY FLAWLESS**

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**GRADING RESULTS**

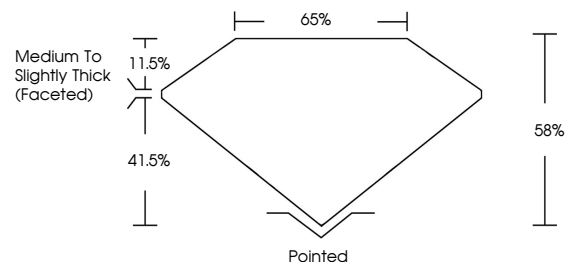
Carat Weight **4.00 CARATS**  
Color Grade **E**  
Clarity Grade **INTERNALLY FLAWLESS**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG764660773**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

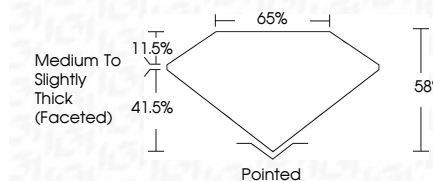
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**OVAL BRILLIANT**  
13.27 X 8.93 X 5.18 MM  
4.00 CARATS  
E  
Color Grade  
Clarity Grade  
Table  
Depth  
Girdle  
Medium to Slightly Thick (Faceted)  
Pointed  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG764660773**  
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